

ISO 50001

Management System Certificate



Certificate Number : JQA-ER0015

Organization :

GlobalWafers Japan Co., Ltd.

Head Office / Niigata Plant

6-861-5 HIGASHIKO, SEIRO-MACHI, KITAKANBARA-GUN, NIIGATA, JAPAN

JQA certifies that the above organization operates the Energy Management System, within the scope of the Appendix attached, which has been assessed and found to comply with the requirements of;

ISO 50001:2018 / JIS Q 50001:2019

Registration Date : December 6, 2024

Expiry Date : December 5, 2027

Feel free to contact JQA for the validity of this certificate.

A handwritten signature in black ink, appearing to read "H. Ishii".

HIROAKI ISHII
PRESIDENT

1-25 KANDASUDACHO, CHIYODA-KU, TOKYO, JAPAN

JAPAN QUALITY ASSURANCE ORGANIZATION
To be used in conjunction with attached Appendix.



ISO 50001

Appendix



Certificate Number : JQA-ER0015

1 / 1

Organization :

GlobalWafers Japan Co., Ltd.

Head Office / Niigata Plant

Scope of Registration :

THE DESIGN / DEVELOPMENT AND MANUFACTURE OF SINGLE CRYSTAL SILICON AND SILICON WAFER

ASSOCIATED ORGANIZATION:

- GlobalWafers Japan Co., Ltd. SEKIKAWA PLANT
278 TATSUTASHIN, SEKIKAWA-MURA, IWAFUNE-GUN, NIIGATA, JAPAN
- MEMC JAPAN LTD. UTSUNOMIYA PLANT
11-2 KIYOHARA INDUSTRIAL PARK, UTSUNOMIYA-CITY, TOCHIGI, JAPAN
[THE MANUFACTURE OF SILICON WAFER]
- GlobalWafers Japan Co., Ltd. TOKUYAMA PLANT
2-1-32 EGUCHI, SHUNAN-SHI, YAMAGUCHI, JAPAN
[MANUFACTURING OF SILICON EPITAXIAL WAFER]
- GlobalWafers Japan Co., Ltd. OGUNI SILICON CRYSTAL CENTER
378 OGUNI-MACHI, OGUNI-MACHI, NISHI-OKITAMA-GUN, YAMAGATA, JAPAN
[THE MANUFACTURE OF SILICON SINGLE CRYSTAL]

Registration Date : December 6, 2024

A handwritten signature in black ink, appearing to read "H. Ishii".

HIROAKI ISHII
PRESIDENT

Expiry Date : December 5, 2027

Feel free to contact JQA for the validity of this certificate.

JAPAN QUALITY ASSURANCE ORGANIZATION

This Appendix is an integral part of the Certificate and should only be used in conjunction with the Certificate.

